

**AMENDMENTS TO THE SPECIFICATION**

*Please amend paragraph [0023] beginning on page 10 and ending on page 11 as follows:*

[0023] In a first embodiment of the present invention, a method of manufacturing the molding device 60 will be described with reference to FIG. 5A to FIG. 5E. First, as shown in FIG. 5A, prism unevenness grooves 82 are formed on the surface of a brass plate by a grinding process employing, for example, a bit 80 to prepare a master 84. By a mechanical machining using the bit 80, a pitch width P of the prism unevenness grooves 82 are formed at equal distances on the surface of the master 84, from 0.07 to 0.08 mm. Next, as shown in FIG. 5B, the surface of the master 84 provided with the prism unevenness grooves 82 is electroplated with nickel to form a nickel electrotype 86. Subsequently, as shown in FIG. 5C, the nickel electrotype 86 is separated from the master 84 to provide a nickel electrotype 86 having the prism unevenness grooves 82. Then, the rear and side surfaces of the electrotype 86 are machined to complete the nickel stamper 54. In this case, the stamper 54 has a thickness of about 0.3 to 0.4 mm. Finally, the manufactured stamper 54 is put on the core material portion 58 with a thickness of 20 to 30 mm to perform an electrotyping work for fixing the stamper 54 and the core material portion 58. In other words, as shown in FIG. 5E, the surfaces of the stamper 54 and the core inside material portion 58 are electroplated with nickel to form

a nickel sealing electroplate 56. The core material portion 58 may be made from the same metal material (e.g., nickel) as the stamper 54 or a different metal material (e.g., Prehardening steel). Consequently, the integral-type molding device ~~69-60~~ in which the stamper 54 and the core material portion 58 are sealed together by the nickel electroplate 56 is completed.